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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Matthias SLODOWSKI

Title:

APPARATUS AND METHOD FOR THIN-LAYER

METROLOGY

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Examiner:

Gordon J. Stock, Jr.

Art Unit:

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Confirmation No.

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REPLY UNDER 37 CFR 1.116

Mail Stop Box AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

This communication is responsive to the Final Office Action dated June 13, 2007, concerning the above-referenced patent application.

Remarks/Arguments begin on page 2 of this document.